Title: METHOD FOR EVALUATING PIEZOELECTRIC FIELDS Inventors: TAKEUCHI et al.

Inventors: TAKEUCHI et al.
Atty Docket No.: 402961
Leydig, Voit & Mayer 202-737-6770

Fig. 1

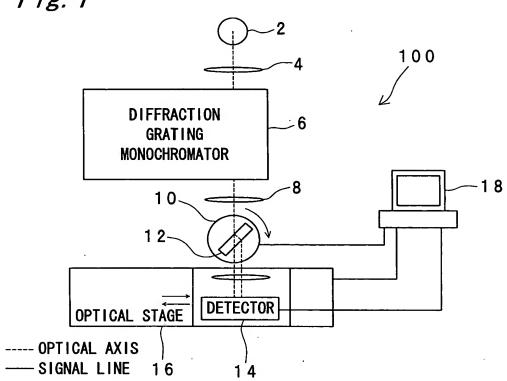


Fig. 2

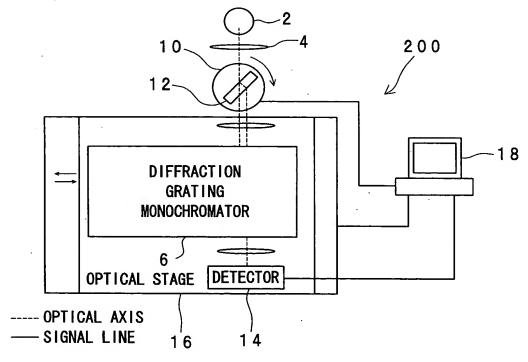
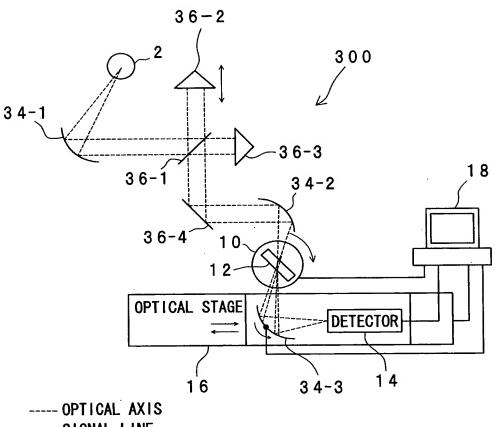


Fig. 3

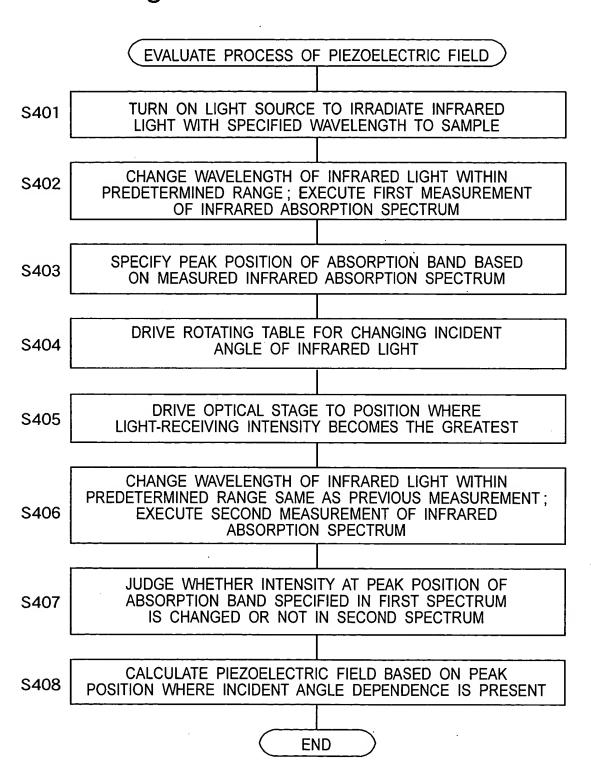


-SIGNAL LINE

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Fig.4



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Fig. 5

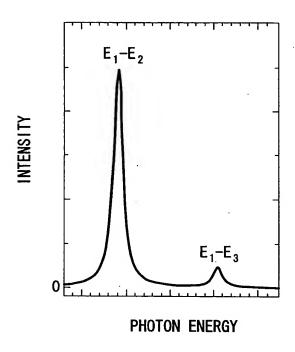


Fig. 6

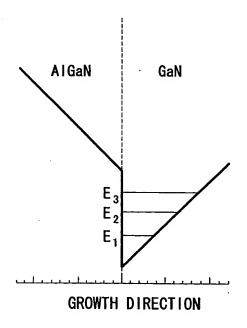
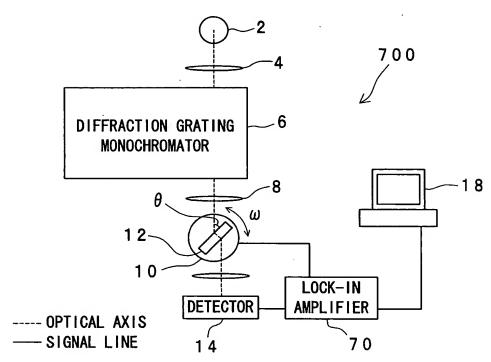


Fig. 7



34-1

36-1

36-2

W
DETECTOR

AMPLIFIER

---OPTICAL AXIS
---SIGNAL LINE

8 0

14

34-3